



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of
**Kari Härkönen, Mark Doczy,
Teemu Lang and Nathan E. Baxter**

Application No. 10/642,426

Filed: August 15, 2003

For: **DEPOSITION OF CARBON- AND
TRANSITION METAL-CONTAINING
THIN FILMS**

Group Art Unit: 1762

Examiner: Bret P. Chen

Date: July 29, 2005

Confirmation No. 9896

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July 29, 2005

Linda Stuwe
Date
Signature
Linda Stuwe
Typed Name

TRANSMITTAL LETTER

TO THE COMMISSIONER FOR PATENTS:

Enclosed for filing in the above-referenced application are the following:

- ☒ Petition for Extension of Time Under 37 CFR § 1.136(a)
- ☒ Amendment
- ☒ Return receipt postcard
- ☒ Check for \$120.00

The Commissioner is hereby authorized to charge any additional fees which may be required in connection with filing of these papers, or credit overpayment, to Account No. 19-4455.

Respectfully submitted,

Planar Systems, Inc.

By Kassim M. Ferris
Kassim M. Ferris
Registration No. 39,974

STOEL RIVES LLP
900 SW Fifth Avenue, Suite 2600
Portland, OR 97204-1268
Telephone: (503) 224-3380
Facsimile: (503) 220-2480
Attorney Docket No. 11429/19:2